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REQUEST **FOR** 

# **CONTINUED EXAMINATION (RCE) TRANSMITTAL**

Subsection (b) of 35 U.S.C. § 132, effective on May 29, 2000, provides for continued examination of an utility or plant application filed on or after June 8, 1995.

See The American Inventors Protection Act of 1999 (AIPA).

Application Number	09/602,395
Filing Date	June 22, 2000
First Named Inventor	John T. Moore
Group Art Unit	2813
Examiner Name	Pham, Thanhha S.
Attorney Docket Number	MI22-1384

	This is a Request for Continued Examination (RCE) under 37 C.F.R. § 1.114 of the above-identified application.  NOTE: 37 C.F.R. § 1.114 is effective on May 29, 2000. If the above-identified application was filed prior to May 29, 2000, applicant may wish to consider filing a continued prosecution application (CPA) under 37 C.F.R. § 1.53 (d) (PTO/SB/29) instead of a RCE to be eligible for the patent term adjustment provisions of the AIPA. See Changes to Application Examination and Provisional Application Practice, Final Rule, 65 Fed. Reg. 14865 (Mar. 20, 2000), 1233 Off. Gaz. Pat. Office 47 (Apr. 11, 2000), which established RCE practice.		
	1. Submission required under 37 C.F.R. § 1.114  a. Previously submitted i. Consider the amendment(s)/reply under 37 C.F.R. § 1.116 previously filed on (Any unentered amendment(s) referred to above will be entered).  ii. Consider the arguments in the Appeal Brief or Reply Brief previously filed on iii. Other  b. Enclosed i. Amendment/Reply  ii. Affiction://Opendenting(s)		
	b. X Enclosed i. X Amendment/Reply ii. Affidavit(s)/Declaration(s) iii. X Information Disclosure Statement (IDS) w/PT0-1449 and copies of cited references iv. X Other Return receipt postcard		
	2. Miscellaneous  a. Suspension of action on the above-identified application is requested under 37 C.F.R. § 1.103(c) for a period of months. (Period of suspension shall not exceed 3 months; Fee under 37 C.F.R. § 1.17(i) required)  b. Other  3. Fees The RCE fee under 37 C.F.R. § 1.17(e) is required by 37 C.F.R. § 1.114 when the RCE is filed.		
	The Director is hereby authorized to charge the following fees, or credit any overpayments, to Deposit Account No23-0925  i. RCE fee required under 37 C.F.R. § 1.17(e)  ii. Extension of time fee (37 C.F.R. §§ 1.136 and 1.17)   12/12/2002 AMDMDAF1 00000075 09602395  iii. X Other any deficiency 01 FC:1801 740.00 gp  b. X Check in the amount of \$ 740.00 enclosed		
c. Payment by credit card (Form PTO-2038 enclosed)			
1	SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT REQUIRED		
	Name (Print /Type) Jennifer J. Taylor, Ph.D. Registration No. (Attorney/Agent) 48,711		
J	Signature (Jennify) auton Date // comber 9, 2002		
1	CERTIFICATE OF MAILING OR TRANSMISSION		
	I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner For Patents, Box RCE, Washington, DC 20231, or facsimile transmitted to the U.S. Patent and Trademark Office on:		
İ	Name (Print/Type) EV182657037		
-	Signature Date		

Burden Hour Statement: This form is estimated to take 0.2 hours to complete. Time will vary depending upon the needs of the individual case. Any comments on the amount of time you are required to complete this form should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, Washington, DC 20231. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND Fees and Completed Forms to the following address: Assistant Commissioner for Patents, Box RCE, Washington, DC 20231.

#21 2000000 1-13.03

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Filing Date June 22, 2000
Inventor John T. Moore
Assignee Micron Technology, Inc.
Group Art Unit 2813
Examiner Pham, Thanhha S.
Attorney's Docket No. MI22-1384
Title: Methods of Forming Oxide Regions Over Semiconductor Substrates

Title. Wellious of Forming Oxide Regions Over Semiconductor Substitutes

## PRELIMINARY AMENDMENT TO ACCOMPANY RCE FILING

To:

**BOX RCE** 

**Assistant Commissioner for Patents** 

Washington, D.C. 20231

From:

Jennifer J. Taylor, Ph.D. (Tel. 509-624-4276; Fax 509-838-3424)

Wells St. John P.S.

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### <u>AMENDMENTS</u>

### **Amended Claims**

None.